



PTO/SB/08A (08-03)

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Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

Application Number	10/730527
Filing Date	12/08/2003
First Named Inventor	Junaid Ahmed Siddiqui
Art Unit	1755
Examiner Name	
Attorney Docket Number	06354ZP USA

Sheet	1	of	2
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U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
mm		US- 5,527,423	06/18/1996	Matthew Neville, et al	
mm		US- 6,063,306	05/16/2000	Vlasta Brusica Kaufman, et al	
mm		US- 6,309,560 B1	10/30/2001	Vlasta Brusica Kaufman, et al	
mm		US- 5,340,370	08/23/1994	Kenneth C. Cadien, et al	
mm		US- 5,516,346	05/14/1996	Kenneth C. Cadien, et al	
mm		US- 5,836,806	11/17/1998	Kenneth C. Cadien, et al	
mm		US- 5,993/686	11/30/1999	Christopher C. Streinz, et al	
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
mm		JP 1997168966A	06/30/1997	Mitsubishi Chemical Corp.		✓

Examiner Signature		Date Considered	2/25/05
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.18 if possible. ⁶Applicant is to place a check mark here if English language translation is attached.

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				Art Unit	1755	
Examiner Name						
Sheet	2	of	2	Attorney Docket Number	06354ZP USA	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
mm		B.L. MUELLER, Polishing Surfaces for Integrated Circuits, Chemtech, 02/1998, pp. 38-46.	✓
mm		H. LANDIS, Thin Solid Films, 1992, 220, p. 1. (no months)	✓
mm		Surfynol, Dynol, and EnviroGem Additives Reference Guide, 2003, Air Products and Chemicals, Inc., Allentown, PA. (no months)	✓
mm		S. SUNDARAM, et al, Effect of Surfactant on CMP Slurry Performance, CMC Conference, Univ. of AZ, Phoenix, 2001, P. 1-10. (no months)	✓
mm		V.A. WELLS, et al, Role of Surfactants on CMP Slurry Performance, CMC Conference, Univ. of AZ, Phoenix, 2002, P. 1-12. (no months)	✓
mm		S. SUNDARAM, et al, Surfactant Interaction With Cu CMP Slurries (no date)	✓
mm		McCutcheon's Volume 1: Emulsifiers & Detergents 1999, North America, The Manufacturing Confectioner Pub. Co., P. (no month)	✓

Examiner Signature		Date Considered	2/25/05
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Sheet	1	of	1	Attorney Docket Number	06354ZP USA

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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>Ma</i>		B.L. MUELLER, Polishing Surfaces for Integrated Circuits, Chemtech, 02/1998, pp. 38-46.	
<i>nr</i>		H. LANDIS, Thin Solid Films, 1992, 220, p. 1-7. <i>(no months)</i>	

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